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#14(EDS)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/885,393
Filing Date June 19, 2001
Inventor Richard Holscher et al.
Assignee Micron Technology, Inc.
Group Art Unit 1756
Examiner Kathleen Duda
Attorney's Docket No. MI22-1694
Title: Semiconductor Processing Methods

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Dated:

12/20/02

Respectfully submitted,

By:



David G. Latwesen, Ph.D.
Reg. No. 38,533

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